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APR 18 2006

S/N 10/804,610

PATENTIN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: KITAOKA, et al. Examiner: T. Ho
Serial No.: 10/804,610 Group Art Unit: 2818
Filed: March 18, 2004 Docket: 10873.1420US01
Title: METHOD OF MANUFACTURING GROUP III NITRIDE
SUBSTRATE AND SEMICONDUCTOR DEVICE

CERTIFICATE UNDER 37 CFR 1.6(d): I hereby certify that this paper is being transmitted by facsimile to the
U.S. Patent and Trademark Office on April 18, 2006.

By: Peggy Kerkhove
Name: Peggy Kerkhove

INFORMATION DISCLOSURE STATEMENT (37 C.F.R. § 1.97(c))

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

With regard to the above-identified application, the items of information listed on the enclosed Form 1449 are brought to the attention of the Examiner. Applicants hereby bring attention to the Examiner that they have three commonly assigned co-pending applications, Serial No. 10/758,815 (US Publication No. 2004-0147096) filed January 16, 2004, Serial No. 10/884,252 (US Publication No. 2005-0011432) filed July 2, 2004 and Serial No. 10/969,791 (US Publication No. 2005-0082564) filed October 19, 2004.

This statement should be considered because it is submitted before the mailing date of a first Office Action on-the-merits after filing a Request for Continued Examination under 37 C.F.R. § 1.114. Accordingly, no fee is due for consideration of the items listed on the enclosed Form 1449.

In accordance with 37 C.F.R. § 1.98(a)(2), a copy of each foreign document or other information listed on the enclosed Form 1449 is provided. As this application was filed after June 30, 2003, copies of the cited U.S. Patent Documents are not included.

noted,
TH
06/2006

Date Mailed: April 18, 2006

Sheet 1 of 1

FORM 1449* INFORMATION DISCLOSURE STATEMENT IN AN APPLICATION (Use several sheets if necessary)	Docket Number: 10873.1420US01	Application Number: 10/804,610
	Applicant: KITAOKA, et al.	
	Filing Date: March 18, 2004	Group Art Unit: 2818

U.S. PATENT DOCUMENTS							
EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
TH	6,121,121	September, 2000	Koide	438	481		
↓	6,503,610	January, 2003	Hiramatsu, et al.	428	210		
	6,667,252	December, 2003	Miyajima, et al.	438	796		
	2005/0082564	April, 2005	Kitaoka, et al.	257	103		
FOREIGN PATENT DOCUMENTS							
	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
TH	3409576	March, 2003	Japan	 	 	Abstract	
TH	2000-357663	December, 20003	Japan			Abstract	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
TH		Kawamura, et al., "Growth of a Large GaN Single Crystal Using the Liquid Phase Epitaxy (LPE)Technique", Jpn. J. Appl. Phys., vol. 42, part 2, no. 1A/B, January 15, 2003, pp. L4-L6					

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PATENT TRADEMARK OFFICES

EXAMINER	/Tu Tu Ho/ (06/16/2006)	DATE CONSIDERED	06/16/2006
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form for next communication to the Applicant.

*Substitute Disclosure Statement Form (PTO-1449)

Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE